PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date	
Akira Noda	11/08/2009	
Toshiyuki Shirai	12/02/2009	
Masahiro Ikegami	11/23/2009	
Shu Nakamura	11/30/2009	
Hiroyuki Daido	12/10/2009	
Kouji Noda	12/17/2009	

RECEIVING PARTY DATA

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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12600540

CORRESPONDENCE DATA

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PATENT 501086585 REEL: 023904 FRAME: 0952

12600540

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ATTORNEY DOCKET NUMBER: W2867US

NAME OF SUBMITTER: Gerald E. Hespos

Total Attachments: 3
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PATENT REEL: 023904 FRAME: 0953

ASSIGNMENT

For value received, We,

Akira NODA, Toshiyuki SHIRAI, Masahiro IKEGAMI, Shu NAKAMURA, residing at c/o Institute for Chemical Research, Kyoto University, Gokasho, Uji-shi, Kyoto 611-0011 Japan,

Hiroyuki DAIDO, residing at c/o Kansai Photon Science Institute, Japan Atomic Energy Agency, 1, Umemidai 8-chome, Kizukawa-shi, Kyoto 619-0215 Japan, and

Kouji NODA, residing at National Institute of Radiological Sciences, 9-1, Anagawa 4-chome, Inage-ku, Chiba-shi, Chiba 263-8555 Japan,

hereby sell, assign, and transfer to **KYOTO UNIVERSITY**, having a place of business at 36-1, Yoshida-honmachi, Sakyo-ku, Kyoto-shi, Kyoto 606-8501 Japan, and

NATIONAL INSTITUTE OF RADIOLOGICAL SCIENCES, having a place of business at 9-1, Anagawa 4-chome, Inage-ku, Chiba-shi, Chiba 263-8555 Japan, and its successors, assigns, and legal representatives, the entire right, title, and interest for all countries including the United States of America, in and to certain inventions relating to

ION BEAM CONTROL APPARATUS AND METHOD

described in an application for Letters Patent of the United States,

[] having an oath or declaration by me/us executed on even date herewith;
[XX] bearing Serial No. 12/600,540 and filed on November 17, 2009, and all patents which may be granted therefor, and all divisions, reissues, continuations and extensions thereof, and authorize and request the Commissioner of Patents and Trademarks to issue all patents on said improvements or resulting therefrom to said Company as assignee of the entire interest, and covenant that I/We have full right so to do, and agree that I/We will communicate to said Company or its representatives any facts known to me/us respecting said improvements and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuing and reissue applications, make all rightful oaths and generally do everything possible to aid said Company, its successors, assigns, and nominees, to obtain and enforce proper protection for said invention in the United States.

The Assignor(s) hereby authorizes and requests the attorneys of CASELLA & HESPOS LLP, New York, NY, to insert in the spaces provided above the filing date, serial number, and attorney docket number of said application if not previously inserted.

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Signature	Akira NODA	Date 8, November, 2009
Signature	Toshiyuki SHIRAI	Date 2 December 2009
Signature	Masahiro IKEGAMI	Date 23, November, 2009
Signature ₋	Shu Nakamura Shu NAKAMURA	Date 30 November, 2009
Signature <u>f</u>	Hiroyuki DAIDO	Date 10, December, 2009

Signature	Kouji	Noda	Date	17	Dec.	2009
	Kouii NODA					

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RECORDED: 02/05/2010